

Notice of References CitedApplication/Control No.
09/920,275Applicant(s)/Patent Under
Reexamination
CHRYSLER ET AL.Examiner
Scott B. GeyerArt Unit
2829

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,696,665	12-1997	Nagy	361/723
	B	US-5,650,639	07-1997	Schrantz et al.	257/77
	C	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Liu et al., "DIAMOND CHEMICAL VAPOR DEPOSITION: Nucleation and Early Growth Stages", 1995, pages 1-7.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a))
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.